

Ifu



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

In Su Kim

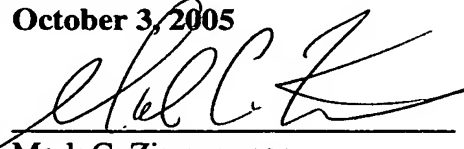
Serial No.: 10/758,188

For: Methods of Fabricating -
Semiconductor Devices

Filed: January 15, 2004

Group Art Unit: 2891

Examiner: Bradley Smith

) I hereby certify that this paper is
) being deposited with the United
) States Postal Service as first-class
) mail, postage prepaid, in an
) envelope addressed to: Mail Stop
) Amendment, Commissioner for
) Patents
) P.O. Box 1450
) Alexandria, VA 22313-1450, on
) this date:
) **October 3, 2005**
) 
) **Mark C. Zimmerman**
) **Registration No. 44,006**
) **Attorney for Applicants**

RESPONSE TO THE OFFICE ACTION DATED JULY 1, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated July 1, 2005, please enter the following amendments and consider the following remarks:

Amendments to the Specification begin on page 2 of this paper.

The Status of the Claims is reflected in the listing of claims that begins on page 3 of this paper.

Amendments to the Drawings begin on page 5 of this paper.

Remarks begin on page 6 of this paper.

An Appendix including amended drawing figures is attached following page 7 of this paper.